Supporting Information for

Ta-Doped Sb2Te Allows Ultrafast Phase-Change Memory with

Excellent High-Temperature Operation Characteristics

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Supplementary Figures

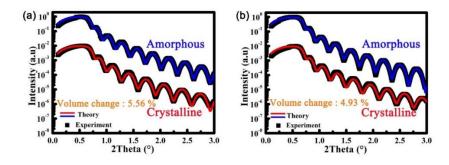


Fig. S1 X-ray reflectivity (XRR) measurement results and fitting, for (**a**) ST21 (**b**) TaST21-1. Black lines indicate the original data, red lines indicate the fitting results of the amorphous state, and blue lines indicate the fitting results of the crystalline state

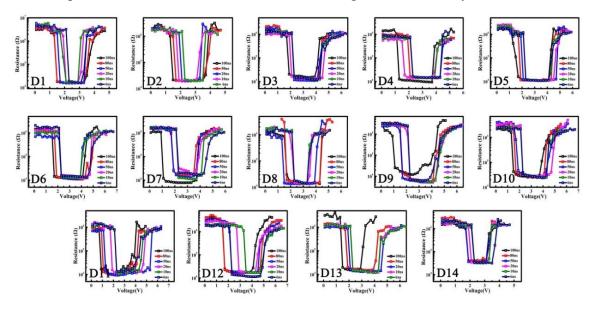


Fig. S2 Performance of devices in a 14-bit array based on TaST21-1

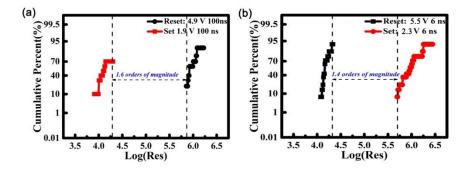


Fig. S3 Cumulative distribution of Set and Reset resistance of devices in the 14-bit array based on TaST21-1. (**a**) The measurement results when the pulse width is fixed at 100 ns. The optimal condition of Set and Reset operation is 1.9 V and 4.9 V, respectively. (**b**) The measurement results when the pulse width is fixed at 6 ns. The optimal condition of Set and Reset operation is 2.3 and 5.5 V, respectively

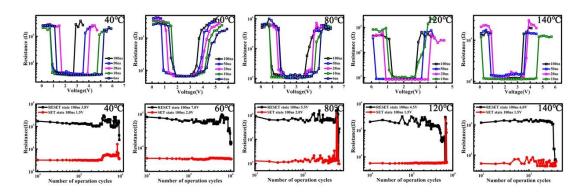


Fig. S4 Performance of TaST21-1 based phase change memory at different ambient temperatures

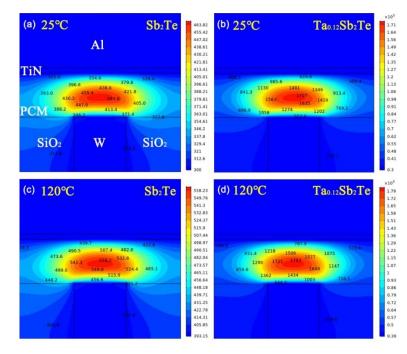


Fig. S5 Temperature distribution of a phase change memory based on ST21 and TaST21-1 at different ambient temperatures

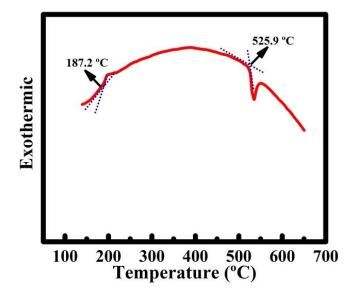


Fig. S6 Differential scanning calorimetry (DSC) measurement of a TaST21-1 film. The heating rate is 10 $^{\circ}$ C min⁻¹

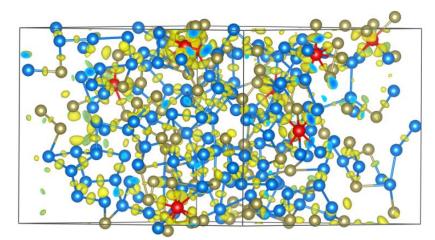


Fig. S7 Structure model of a-TaST21 with CDD